



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

1/4/02
J. Lee, Jr.

In re the Application of

Akira SATO

Group Art Unit: 2825

Application No.: 09/424,500

Examiner: G. Lee, Jr.

Filed: February 22, 2000

Docket No.: 104788

For: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE, MOLDING DEVICE FOR SEMICONDUCTOR DEVICE, AND SEMICONDUCTOR DEVICE

REQUEST FOR APPROVAL OF DRAWING CORRECTIONS

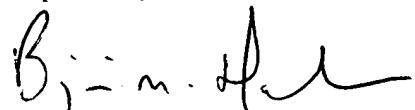
Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

The Examiner is requested to review and approve the proposed corrections to Figure 2, marked in red on the attached copy of such drawing figure.

Upon approval by the Examiner, and upon allowance of this application, the formal drawings will be corrected.

Respectfully submitted,



James A. Oliff
Registration No. 27,075

Benjamin M. Halpern
Registration No. 46,494

RECEIVED
JUL 18 2002
TELECOPY CENTER 2800
JAO:BMH/gpn

Date: July 15, 2002

OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400